

# Special Issue

## Recent Advances in Thin Film Electronic Devices

### Message from the Guest Editor

Thin film electronic devices have been attracting more and more attention because they can be used in many industrial fields, such as flat panel displays, energy devices, sensors, memories, and so on. This Special Issue plans to give an overview of the most recent advances in thin film electronic devices in the abovementioned fields. This Special Issue is aimed at providing selected contributions on advances in the physics, processing, design, characterization, and applications of novel thin film electronic devices. Potential topics include, but are not limited to: thin film transistors; thin film solar cells; thin film sensors; thin film memories; device physics about novel thin film electronic devices; process development of novel devices; characterization of novel thin films and devices; design of novel devices and circuits.

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### Guest Editor

Dr. Chengyuan Dong

Department of Electronic Engineering, Shanghai Jiao Tong University, Shanghai 200240, China

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### Deadline for manuscript submissions

closed (30 June 2022)



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*Micromachines*  
Editorial Office  
MDPI, Grosspeteranlage 5  
4052 Basel, Switzerland  
Tel: +41 61 683 77 34  
[micromachines@mdpi.com](mailto:micromachines@mdpi.com)

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### Editor-in-Chief

Prof. Dr. Nam-Trung Nguyen

Queensland Quantum and Advanced Technologies Research Institute,  
Griffith University, West Creek Road, Nathan, QLD 4111, Australia

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